

Notice of References Cited

Application/Control No.

10/572,587

Applicant(s)/Patent Under

Reexamination

HIMI ET AL.

Examiner

Vibol Tan

Art Unit

2819

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U.S. PATENT DOCUMENTS

| * | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|--|-----------------|------------------|----------------|
| * | A US-6,236,279 | 05-2001 | Fujii et al. | 331/68 |
| * | B US-6,204,739 | 03-2001 | Sakamoto et al. | 333/219.1 |
| * | C US-6,369,676 | 04-2002 | Sakamoto et al. | 333/219.1 |
| * | D US-6,172,572 | 01-2001 | Kajikawa et al. | 331/96 |
| * | E US-6,016,090 | 01-2000 | Iio et al. | 333/202 |
| * | F US-6,388,541 | 05-2002 | Hiratsuka et al. | 333/134 |
| * | G US-2003/0234695 | 12-2003 | Haruta et al. | 331/68 |
| H | US- | | | |
| I | US- | | | |
| J | US- | | | |
| K | US- | | | |
| L | US- | | | |
| M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|--|-----------------|---------|------|----------------|
| N | | | | | |
| O | | | | | |
| P | | | | | |
| Q | | | | | |
| R | | | | | |
| S | | | | | |
| T | | | | | |

NON-PATENT DOCUMENTS

| * | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|
| U | |
| V | |
| W | |
| X | |

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